

US PTO
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03/01/02

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10084925	FILING DATE 03/01/2002	CLASS 257	SUBCLASS	GAU 2811	EXAMINER Q.Vu
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**APPLICANTS: Nikami Takashi;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2001-275538 09/11/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 020277	
Verified and Acknowledged Examiner's initials			
TITLE : Semiconductor device and method for fabricating the same			

U.S. DEPT. OF COMM./PAT. & TM-PFO-436L(Rev. 12-91)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Draw.	Fig.s Draw.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner		
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